

AMENDMENTS TO THE SPECIFICATION:

On page 1 after the title, please insert the following:

RELATED APPLICATIONS

The present application is based on International Application No. PCT/FR03/01012, filed on April 1, 2003, entitled "PROCESS FOR FABRICATING A MICROSTRUCTURE CONTAINING A VACUUM CAVITY, AND MICROSTRUCTURE", which in turn corresponds to French Application FR 02/04628 filed on April 12, 2002, and priority is hereby claimed under 35 USC 119 based on these applications. Each of these applications are hereby incorporated by reference herein in their entirety into this application.

FIELD OF THE INVENTION--

On page 1 after line 17, please insert the following header:

--BACKGROUND OF THE INVENTION --

On page 4 after line 31 please insert the following header:

--SUMMARY OF THE INVENTION --

On page 5 after line 35, please enter the following header:

--BRIEF DESCRIPTION OF THE DRAWINGS--

On page 6 after line 6, please insert the following header:

--DETAILED DESCRIPTION OF THE INVENTION --